PATENT APPLICATION

RESPONSE UNDER 37 CFR §1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER ART UNIT 3742

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Atsuo KONDO et al.

Group Art Unit: 3742

Application No.: 10/581,748

Examiner:

Q. VAN

Filed: June 6, 2006

Docket No.: 128342

For:

PLASMA GENERATING ELECTRODE, ITS MANUFACTURING METHOD, AND

PLASMA REACTOR

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the March 30, 2009 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.